

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application:	:	Group Art Unit: 1744
Ming-Chun Chou	:	
	:	
Serial Number: 10/823,955	:	Examiner: Karls, Shay Lynn
	:	
Filed: April 14, 2004	:	Confirmation No.: 5433
	:	
Title: Brush Positioning Device For A Wafer Cleaning Station	:	Attorney Docket No.: N1161-00026
	:	

Mail Stop **Amendment**
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

This paper is responsive to the Office Action mailed on August 28, 2007 in the above-captioned application. Kindly enter the following:

Amendments to the claims are reflected in the claim listing which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.